



PTO/SB/30 (10-91)

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**REQUEST  
FOR  
CONTINUED EXAMINATION (RCE)  
TRANSMITTAL**Address to:  
Commissioner for Patents  
**Box RCE**  
Washington, DC 20231

Application Number	09/218,997
Filing Date	December 22, 1998
First Named Inventor	Teruaki FUKAMI
Art Unit	1744
Examiner Name	Imad Soubra
Attorney Docket Number	8565D-7213 (81839.0077)

**This is a Request for Continued Examination (RCE) under 37 CFR 1.114 of the above-identified application.**  
Request for Continued Examination (RCE) practice under 37 CFR 1.114 does not apply to any utility or plant application filed prior to June 8, 1995, or to any design application. See Instruction Sheet for RCEs (not to be submitted to the USPTO) on page 2.

1. **Submission required under 37 CFR 1.114**

- a. ☐ Previously submitted
- i. ☐ Consider the amendment(s)/reply under 37 CFR 1.116 previously filed on AUG 29 2002  
(Any unentered amendment(s) referred to above will be entered).
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on TC-1700
- iii. ☐ Other \_\_\_\_\_
- b. ☒ Enclosed
- i. ☐ Amendment/Reply
- iii. ☐ Information Disclosure Statement (IDS)
- ii. ☐ Affidavit(s)/Declaration(s)
- iv. ☒ Other Proposed Preliminary Amendment For Discussion With Applicant

2. **Miscellaneous**

- a. ☐ Suspension of action on the above-identified application is requested under 37 CFR 1.103(c) for a period of \_\_\_\_\_ months. (Period of suspension shall not exceed 3 months; Fee under 37 CFR 1.17(i) required)
- b. ☐ Other \_\_\_\_\_

3. **Fees**

The RCE fee under 37 CFR 1.17(e) is required by 37 CFR 1.114 when the RCE is filed.

- a. ☒ The Director is hereby authorized to charge the following fees, or credit any overpayments, to Deposit Account No. 50-1314
- i. ☐ RCE fee required under 37 CFR 1.17(e)
- ii. ☐ Extension of time fee (37 CFR 1.136 and 1.17): 08/28/2002 AMCHDAF1 00000069 09218997
- iii. ☐ Other \_\_\_\_\_
- b. ☒ Check in the amount of \$ 740.00 enclosed 01 FC:179 740.00 OP
- c. ☐ Payment by credit card (Form PTO-2038 enclosed)

**WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.**

**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT REQUIRED**

Name (Print Type)	John P. Scherlach	Registration No. (Attorney Agent)	23,009
Signature	<i>John P. Scherlach</i>	Date	August 19, 2002

**CERTIFICATE OF MAILING OR TRANSMISSION**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner For Patents, Box RCE, Washington, DC 20231, or facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

Name (Print Type)	John P. Scherlach	Date	August 19, 2002
Signature	<i>John P. Scherlach</i>		

**Burden Hour Statement:** This form is estimated to take 0.2 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SENT FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND Fees and Completed Forms to the following address: Assistant Commissioner for Patents, Box RCE, Washington, DC 20231.



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PATENT  
81839.0077

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Teruaki FUKAMI

Serial No: 09/218,997

Filed: December 22, 1998

For: SILICON WAFER STORAGE  
WATER AND SILICON WAFER  
STORAGE METHOD

Art Unit: 1744

Examiner: Imad Soubra

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John P. Scherlacher, Reg. No. 23,009

Name

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Signature

Date

**PROPOSED PRELIMINARY AMENDMENT**

Box RCE

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In conjunction with the filing of an RCE (Request For Continued Examination) for the above-identified application on August 19, 2002, applicant is submitting this Proposed Preliminary Amendment for review by the Examiner and discussion with applicant. The Examiner is requested to review this Proposed Preliminary Amendment and telephone applicant's attorney, John P. Scherlacher at (213) 337-6846 so it can be discussed. The Preliminary Amendment proposed by applicant is as follows:

**IN THE CLAIMS:**

Rewrite claim 1 as follows:

1. (Three Times Amended) A storage water used for storage of a silicon wafer in water, wherein the storage water is ultra pure water containing Cu at a concentration of 0.01 ppb or less.

Cancel claim 3, without prejudice.

Rewrite claim 4 as follows:

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AUG 29 2002

TC 1700